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21283/931A 3750 PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

ZHENGHE HAN et al.

Serial No. 10/541,296

Filed: July 6, 2005

For: SURFACE MODIFICATION
METHOD IN FABRICATING HIGH
TEMPERATURE SUPER
CONDUCTIVE DEVICES

Art Unit: 1793

Examiner: Paul A. Wartalowicz

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Dear Sir:

In response to the Office Action dated July 24, 2008, please amend the above identified application as follows:

01/26/2009 HMARZ1Z 00000009 504367 10541296

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76444/2204479.1

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